

| | Type | Hits | Search Text | DBs |
|----|--------|---------------------------------------------------------------------------------------------------------------------------------|-------------|------------------------------------|
| 1 | BRS 1 | "5157540" PN. | | USPAT |
| 2 | BRS 1 | "5293510" PN. | | USPAT |
| 3 | BRS 1 | "5598293" PN. | | USPAT |
| 4 | BRS 2 | (dram or (dynamic adj random)) and ((relief) with spacer) | | USPAT |
| 5 | BRS 34 | (dram or (dynamic adj random)) and ((ru or ruthenium) with (electrode or node or plate) with (pd or palladium or ni or ni | | USPAT |
| 6 | BRS 9 | (dram or (dynamic adj random)) and ((ru or ruthenium) with (electrode or node or plate) with (pd or palladium or ni or ni | | US-PGPUB; EPO; JPO; DERWENT; IBM T |
| 7 | BRS 2 | "5972722" and atomic | | USPAT |
| 8 | BRS 4 | (dram or (dynamic adj random)) and ((ru or ruthenium) with (electrode or node or plate) with (pd or palladium or ni or ni | | USPAT |
| 9 | BRS 26 | (dram or (dynamic adj random)) and ((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or p | | USPAT |
| 10 | BRS 10 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 11 | BRS 5 | "6011284" | | USPAT |
| 12 | BRS 0 | "09800493" | | US-PGPUB |
| 13 | BRS 0 | "9800493" | | US-PGPUB |
| 14 | BRS 1 | "20010050389" and electroconductive | | US-PGPUB |
| 15 | BRS 1 | "20010050389" and formed | | US-PGPUB |
| 16 | BRS 5 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 17 | BRS 5 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 18 | BRS 2 | "5939744" | | USPAT |
| 19 | BRS 0 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 20 | BRS 1 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 21 | BRS 1 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 22 | BRS 4 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 23 | BRS 3 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 24 | BRS 0 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 25 | BRS 9 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 26 | BRS 0 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | USPAT |
| 27 | BRS 0 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (pd or palladium or ni or nic | | EPO; JPO; DERWENT; IBM TDB |
| 28 | BRS 3 | (((ru or ruthenium or rh or rhodium or iridium or ir or osmium or os or platinum or pt) with (ti or titanium) with ("atomic" | | USPAT |
| 29 | BRS 5 | (((ru or ruthenium) with (ti or titanium) with ("atomic" or "%" or "percent" or "major" or "main")) and ((ru or ruthenium) | | USPAT |
| 30 | BRS 1 | "20010050389" and (electroconductive with between) | | US-PGPUB |
| 31 | BRS 1 | (((adhesive or adhesiveness) with (electrode or node or plate) with (pd or palladium or ni or nickel or cobalt or co or ti | | USPAT |
| 32 | BRS 8 | (((adhesive or adhesiveness) with (electrode or node or plate) with (pd or palladium or ni or nickel or cobalt or co or ti | | USPAT |
| 33 | BRS 1 | (((adhesive or adhesiveness) with (electrode or node or plate) with (pd or palladium or ni or nickel or cobalt or co)) | | USPAT |
| 34 | BRS 1 | (((adhesive or adhesiveness) with (pd or palladium or ni or nickel or cobalt or co)) and ferroelectric and capacitor an | | USPAT |
| 35 | BRS 9 | (((adhesive or adhesiveness) with (pd or palladium or ni or nickel or cobalt or co)) and capacitor and (semiconducto | | USPAT |
| 36 | BRS 29 | (((adhesive or adhesiveness or adhesion) with (pd or palladium or ni or nickel or cobalt or co)) and capacitor and (s | | USPAT |
| 37 | BRS 1 | ((("ruo.sub.2" or ((ruthenium or iridium) adj oxide) or "iro.sub.2") with (pd or palladium or ni or nickel or cobalt or co or | | USPAT |
| 38 | BRS 3 | ((("ruo.sub.2" or ((ruthenium or iridium) with oxide) or "iro.sub.2") with (pd or palladium or ni or nickel or cobalt or co o | | USPAT |
| 39 | BRS 3 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | USPAT |
| 40 | BRS 1 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | US-PGPUB; EPO; JPO; DERWENT; IBM T |
| 41 | BRS 13 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | USPAT |
| 42 | BRS 0 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | USPAT |
| 43 | BRS 0 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | USPAT |
| 44 | BRS 0 | ((("ruo.sub.2" or ((ruthenium or iridium or ru or ir) with oxide) or "iro.sub.2" or "ruo2" or "iro2") with (pd or palladium or | | USPAT |

[illegible]